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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Shen et al.	Group Art Unit: 1746
Serial No: 09/507,629	Examiner: Allan W. Olsen
Filed: February 18, 2000	Attorney Docket No 001945 USA P03/SILICON/JB
Title: SELF-CLEANING PROCESS FOR ETCHING SILICON-CONTAINING MATERIAL	July 23, 2002 San Francisco, California

AMENDMENT

Box Fee Amendment  
Commissioner for Patents  
Washington, D.C. 20231

Examiner Olsen:

March 29, 2002, and is being filed within four months thereof with a request for one month extension of time

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By Examiner  
Date March 29, 2002

Dated July 23, 2002

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